## Honeywell Docket No. H0002233.33717 US - 4018

Buchalter Docket No.: H9925-2905

## IN THE CLAIMS

- 1. (Currently Amended) A plating system comprising:
  - an elongated upper channel formed by a plurality of two upper shields and an elongated lower channel formed by a plurality of two lower shields, wherein each channel is separated by a gap between the upper and lower shields; and
  - a plating solution horizontal sparger comprising a series of inlets oriented to direct any plating solution flowing through the inlets directly into one and towards another of the upper and lower channels.
- 2. (Original) The system of claim 1 further comprising:

an anode; and

- a substantially planar cathode comprising a first surface conductive surface, a second conductive surface, and a perimeter edge, the first conductive surface and second conductive surfaces being substantially parallel to each other arid positioned on opposite sides of the cathode; wherein the sparger is positioned at least as close to the perimeter edge of the cathode as to either of the first or second conducting surfaces.
- (Original) The system of claim 2 wherein the sparger directs any plating solution flowing through the inlets towards the cathode in a plane substantially coplanar with the cathode.
- 4. (Original) The system of claim 3 wherein:
  - each of the upper and lower channels comprises two substantially planar and parallel non electrically conductive sides that are substantially parallel to the cathode; and
  - the cathode is positioned at least partially within each of the upper and lower channels between the non electrically conductive sides.
- 5. (Original) The system of claim 4 wherein:
  - the upper and lower channels are positioned opposite each other and are

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separated from each other, the separation between the channels forming a pair of solution egress slots; and the channels are adapted to prevent current from flow between the anode and cathode other than through the egress slots.

- (Original) The system of claim 5 wherein the egress slots are positioned approximately parallel to a center line of the cathode.
- 7. (Original) The system of claim 6 wherein the cathode comprises a dielectric substrate and the conductive surfaces are adapted to promote the formation of heat spreaders on the dielectric substrate.
- 8. (Original) The system of claim 1 wherein each of the upper channel and lower channel have a width less than or equal to one inch.
- (Previously Presented) The system of claim 1 wherein the horizontal sparger directs any plating solution flowing through the inlets into the lower channel and towards the upper channel.
- (Original) The system of claim 1 wherein each of the upper channel and lower channel have a width less than or equal to 0.5 inches.
- 11. (Original) The system of claim 1 wherein each of the upper channel and lower channel have a width less than or equal to 0.5 inches, and the further comprising a plurality of part holding clamps electrically coupled to a power source and positioned within the upper channel or the lower channel.
- 12. (Original) The system of claim 1 further comprising a plurality of anodes positioned outside and along the length of the upper and lower channels.
- 13. (Original) The system of claim 1 wherein the upper channel and lower channel are separated by a distance and at least one of the upper channel and lower channel are adapted to be moved to vary the distance.

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14. (Original) The system of plated to a channel wall wall and an anode.

Claims 15-18: Canceled. (Original) The system of claim 1 wherein the shortest distance from a part being plated to a channel wall is less than the shortest distance between the channel